

UNITED STATES PATENT AND TRADEMARK OFFICE

Tw Receipt

Applicant: EY et al. Serial No.: 10/524,927 Filed: September 29, 2005

Entitled: Utilization of Waste Gas Streams

Dkt. No.: M02B149

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Group No.: 2812 Examiner: n/a

CERTIFICATE OF MAILING

Betty Lee

Printed name of person signing this certificate

Signature of person mailing

Dear Sir:

REQUEST FOR CORRECTED FILING RECEIPT

Attached is a copy of the official filing receipt, mailed January 18, 2006, received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested.

There is an error with respect to the spelling of the first word in the title of the subject application. Please change "Utilisation" to read <u>Utilization</u>. A copy of the Preliminary Amendment which was submitted together with the subject patent application is attached for your reference.

It is believed that the need for correction is not due to any error by applicant and that no fee is due. However, as a precaution, the Commissioner is hereby authorized to charge to Deposit Account No. 02-2865 any fee which may be required. This letter is submitted in triplicate.

Respectfully submitted,

Attorney for Applicants(s)

Ira Lee Zebrak, E

Reg. No. 31,147

The BOC Group, Inc.

Legal Services - Intellectual Property

575 Mountain Ave. Murray Hill, NJ 07974

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Attachments
Official Filing

Official Filing Receipt Preliminary Amendment

ILZ:bjl



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FILING OR 371 TOT CLMS IND CLMS **ART UNIT** FIL FEE REC'D ATTY.DOCKET NO **DRAWINGS** APPL NO. (c) DATE 2 M02B149 18 10/524.927 09/29/2005 2812 1030

CONFIRMATION NO. 1875

FILING RECEIPT

OC000000017851553

Date Mailed: 01/18/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

020411

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MURRAY HILL, NJ 07974-2064

Andrew James Seeley, Bristol, UNITED KINGDOM; James Robert Smith, Blackford Somerset, UNITED KINGDOM;

Power of Attorney: The patent practitioners associated with Customer Number 020411.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/GB03/03670 08/22/2003

Foreign Applications

UNITED KINGDOM 0219735.8 08/23/2002

Projected Publication Date: 04/27/2006

Non-Publication Request: No

Early Publication Request: No

Title

UTILIZATION

-Utilisation of waste gas streams

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Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process simplifies the filing of patent applications on the same invention in member countries, but does not result in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

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N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of: Seeley et al.

Attorney Docket No.: M02B149

International Application No. PCT/GB2003/003670

Group Art Unit:

International Application Filing Date: August 22, 2003

National Application Filed: Concurrently Herewith

Title: Utilisation of Waste Gas Streams

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

37 C.F.R. § 1.115

Dear Sir:

Prior to examining the above-identified application, please amend the above-identified application as follows:

IN THE SPECIFICATION

Please amend the title of the patent application as follows:

Utilisation Utilization of Waste Gas Streams

Please amend page 1 of the Specification by inserting the following paragraph between the Title and the first paragraph:

National Stage application of International Application No. PCT/GB2003/003670 filed August 22, 2003, which claims priority to Great Britain Application No. 0219735.8 filed August 23, 2002.

IN THE CLAIMS

- 1. (currently amended) A process for <u>utilisation utilization</u> of an ammonia-containing waste gas stream from a semiconductor processing step, comprising decomposing ammonia contained in the waste gas stream into hydrogen and nitrogen, passing the gas stream so obtained through a hydrogen separator in order to separate hydrogen gas therefrom, purifying the separated hydrogen gas in a purifier and using the purified hydrogen gas in semiconductor processing.
- 2. (original) A process according to claim 1, in which the semiconductor processing step is gallium nitride epitaxy, the purified hydrogen gas being recycled for use therein.
- 3. (currently amended) A process according to claim 1-or claim 2, in which the hydrogen separator is a pressure swing adsorption system.
- 4. (currently amended) A process according to any one of the preceding-claims 1, in which the purifier is a palladium purifier.
- 5. (currently amended) A process according to any one of the preceding claims 1, in which the ammonia decomposition step comprises contacting the ammonia with a hot catalyst.
- 6. (currently amended) A process according to any of the preceding claims 1, in which the hydrogen gas effluent from the hydrogen separator has a purity of at least 99%.
- 7. (currently amended) A process according to any one of the preceding-claims 1, in which the purified hydrogen effluent from the purifier has a purity of at least 99.99%.
- 8. (currently amended) A process according to any one of the preceding claims 1, in which the hydrogen gas effluent from the hydrogen separator is combined with fresh hydrogen before it is purified in the purifier.
- 9. (currently amended) A process according to any one of the preceding claims 1, in which the purified gas effluent from the purifier is combined with further hydrogen and the combined

hydrogen gas stream is utilised utilized in semiconductor processing.

Claims 10-13 (cancelled)

- 14. (new) A process according to claim 2, in which the hydrogen separator is a pressure swing adsorption system.
- 15. (new) A process according to claim 2, in which the purifier is a palladium purifier.
- 16. (new) A process according to claim 2, in which the ammonia decomposition step comprises contacting the ammonia with a hot catalyst.
- 17. (new) A process according to claim 6, in which the hydrogen gas effluent from the hydrogen separator is combined with fresh hydrogen before it is purified in the purifier.
- 18. (new) A process according to claim 7, in which the purified gas effluent from the purifier is combined with further hydrogen and the combined hydrogen gas stream is utilized in semiconductor processing.
- 19. (new) An apparatus for manufacture of semiconductor products, having a semiconductor processing device and a waste gas recovery loop for recovery of hydrogen, the waste gas recovery loop comprising an ammonia cracking device for receiving waste gases from the semiconductor processing devices and decomposing ammonia therein to form a cracking device effluent containing nitrogen and hydrogen, a hydrogen separator for separation of hydrogen from the ammonia cracking device effluent, a purifier for purifying the separated hydrogen, and a recycle line for recycling purified hydrogen from the purifier to the semiconductor processing device.
- 20. (new) An apparatus according to claim 19, in which the semiconductor processing device is a gallium nitride epitaxy chamber.

- 21. (new) An apparatus according to claim 20, in which the hydrogen separator is a pressure swing absorption system.
- 22. (new) An apparatus according to claim 20, in which the hydrogen purifier is a palladium purifier.

REMARKS

This application is being filed concurrently with the entry of the National Stage (Chapter I) of International Application No. PCT/GB2003/003670 which claims the priority of Great Britain Patent Application No. 0219735.8 under 35 USC 119.

Notably, new claims 19-21 are from cancelled claims 10-13 and only differ from cancelled claims 10-13 in the following ways: (1) any British spellings of words were converted to American spellings; and (2) any multiple dependencies were omitted.

This Preliminary Amendment was considered when calculating the filing fee. Accordingly, the total number of claims specified on the Transmittal Letter is 18 and the number of independent claims is 2.

It is not believed at this time that any additional fee is due. As a precaution, the Commissioner is hereby authorized to charge to Deposit Account No. 02-2865 any additional fee required by this submission.

Respectfully submitted,

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